

**RESPONSE UNDER 37 CFR 1.116  
EXPEDITED PROCEDURE - EXAMINING GROUP 1750**

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Hisaji Oyake et al.  
Application No. : 10/507,429  
Filed : September 10, 2004  
For : METHOD FOR PROCESSING A PHOTORESIST-COATED  
GLASS BOARD, A METHOD FOR MANUFACTURING A  
STAMPER FOR A RECORDING MEDIUM, A METHOD FOR  
MANUFACTURING A RECORDING MEDIUM, A  
PHOTORESIST-COATED GLASS BOARD, A STAMPER FOR A  
RECORDING MEDIUM, AND A RECORDING MEDIUM

Examiner : Martin J. Angebranndt  
Art Unit : 1756  
Docket No. : 890050.503USPC  
Date : April 17, 2007

Mail Stop AF  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT UNDER 37 CFR 1.116

Commissioner for Patents:

In response to the Office Action dated February 5, 2007, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 2 of this paper.

**Remarks** begin on page 8 of this paper.